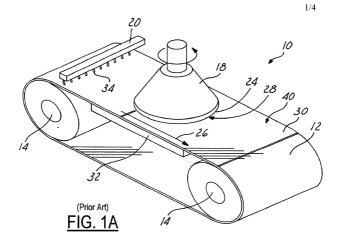
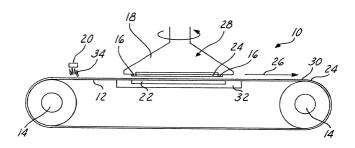
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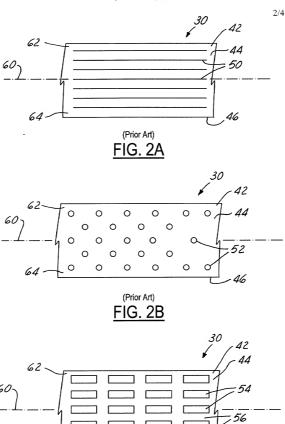




(Prior Art) FIG. 1B

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(Prior Art) FIG. 2C

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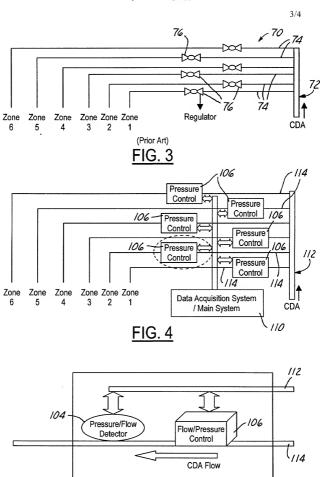


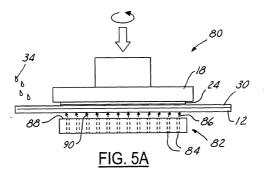
FIG. 4A

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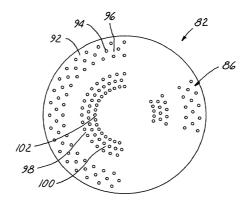


FIG. 5B